MONITORING RESISTANCE OF A THIN-FILM COATING IN REAL TIME

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Abstract	Keywords
One of the priority problems in controlling manufacturing processes of forming thin-film coatings is stopping the process when the electrical resistance of the film reaches a preset value. The study deals with controlling the thickness of a conductive coating by means of its electrical resistance. We suggest an electric measuring system for implementing this control technique, which is aimed at obtaining nanoscale island structures and may be built into the substrate holder of the chamber hardware. We conducted experiments in measuring actual resistance of a thin film during the process of magnetron sputter deposition.	

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